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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Ji-Soo KIM et al.						Docket No. SEC.761D	
Application No. 10/766,932	Filing Date January 30, 2004	Examiner Ram N. KACKAR		Customer No 20987	3. (Group Art Unit 1763	Confirmation No. 3956
METHOD OF AND APPARATUS FOR MANUFACTURING A SEMICONDUCTOR DEVICE USING A POLYSILICON HARD DISK							
STEWN & TRACEUR	_	COMMISSIONER FO					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.							
		CLAIMS AS AM	NENDE!)	=		
	CLAIMS REMAINING	HIGHEST #		BER EXTRA			ADDITIONAL
	AFTER AMENDMENT	PREV. PAID FOR		S PRESENT	_	RATE	FEE
TOTAL CLAIMS	11 -	20 =		0 x	x	\$50.00	\$0.00
INDEP. CLAIMS	2 -	3 =		0 x	к	\$200.00	\$0.00
Multiple Dependen	nt Claims (check if app	olicable)			_		\$0.00
		TOTAL ADDITIONAL F	FEE FC	R THIS AME	ND	MENT	\$0.00
 □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. □ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account □ Any additional filing fees required under 37 C.F.R. 1.16. □ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. 							
STEPHEN R. WHITT Dated: January 27, 2006 Signature							
REG. NO. 34,753 VOLENTINE FRA ONE FREEDOM S 11951 FREEDOM RESTON, VA 2019 TEL. NO. 571-283-		I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on (Date)					
				Signature of	f Pe	erson Mailing Corres	spondence
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UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Ji-Soo KIM et al.

Art Unit: 1763

Application No. 10/766,932

Examiner: Ram N. KACKAR

Filed: January 30, 2004

Confirmation No.: 3956

For:

METHOD OF AND APPARATUS FOR MANUFACTURING A

SEMICONDUCTOR DEVICE USING A POLYSILICON HARD DISK

AMENDMENT

U.S. Patent & Trademark Office Customer Service Window Mail Stop Amendment Randolph Building 401 Dulany Street Alexandria VA 22314

Sir:

In response to the Office Action dated November 17, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.